



ELECTRONIC COPY

LG809653146
Report verification at igi.org



June 11, 2026
IGI Report Number **LG809653146**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **6.81 X 4.81 X 3.21 MM**
GRADING RESULTS
Carat Weight **1.02 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**

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GRADING RESULTS

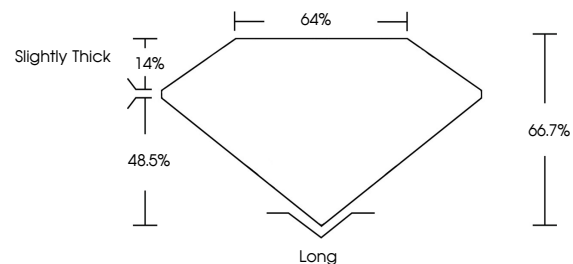
Carat Weight **1.02 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG809653146**

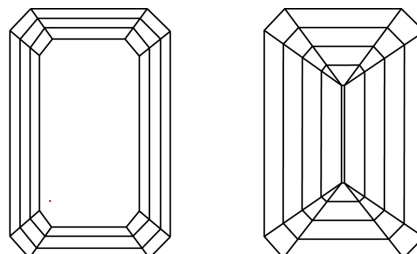
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

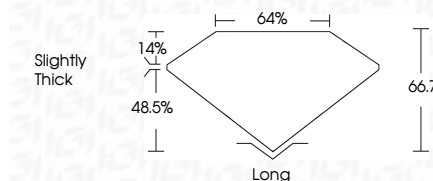
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI

June 11, 2026
IGI Report No. LG809653146
EMERALD CUT
6.81 X 4.81 X 3.21 MM
Carat Weight **1.02 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**
Depth **66.7%**
Table **64%**
Girdle **Slightly Thick**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG809653146**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa